


<b>Search Notes</b>  	<b>Application/Control No.</b>  10730435	<b>Applicant(s)/Patent Under Reexamination</b>  CHANDRASEKHAR ET AL.
	<b>Examiner</b>  Rampuria, Satish S	<b>Art Unit</b>  2191

SEARCHED			
Class	Subclass	Date	Examiner
717	168-178	2/28/2007 (Updated on 7/10/07 and 2/6/08 and 8/20/08)	SR (SR)
717	178	7/10/2007 (updated on 2/6/08 and 8/20/08)	SR (SR)

SEARCH NOTES		
Search Notes	Date	Examiner
East (all database)	2/28/2007 (Updated on 7/10/07 and 2/6/08 and 8/20/08)	SR (SR)
Inventor Name Search (eDAN)	2/28/2007	SR
Plus Search	2/28/2007	SR
Text Search	2/28/2007 (updated on 2/6/08 and 8/20/08)	SR(SR)
NPL (IEEE)	3/2/2007	SR
717/168-178 (text search--see the search notes)	7/10/2007 (updated on 2/6/08 and 8/20/08)	SR (SR)
Wei Zhen, SPE (discussed 101 rejection)	7/23/2007	SR
Ted Vo, Primary Exmr (discussed art used in the rejection and double patenting)	2/11/2008	SR
PGPUB	8/20/2008	SR
Wei Zhen, Lewis Bullock, Satish Rampuria (Appeal conferenc	7/28/2009	SR

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<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>